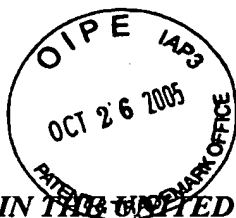


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Amendment
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12-14-05



Atty. Dkt. No. 064951-0204

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Robert BELLMAN et al.
Title: USING DEUTERATED SOURCE GASSES TO FABRICATE LOW
LOSS GeSiON SiON WAVEGUIDES
Appl. No.: 10/608,432
Filing Date: 6/30/2003
Examiner: Hae M. Hyeon
Art Unit: 2839

AMENDMENT UNDER 37 CFR 1.312

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Applicants acknowledge receipt of a Notice of Allowance in the above-captioned application. Prior to payment of the issue fee, please amend the application as follows:

Amendments to the Specification begin on page 2 of this document.

Remarks begin on page 3 of this document.

Please amend the application as follows: